



Gases and Facilities Japan Joint TC Chapter Meeting

Japan Standards Winter 2019 Meetings in conjunction with SEMICON Japan 2019

Tuesday, December 10, 2019

SEMI Japan office, Tokyo, Japan

13:00–15:00

AGENDA

1 Welcome/Call to Order

1.1 Introductions

1.2 Required Elements (Membership Requirements, Antitrust and Intellectual Property Reminders, and Effective Meeting Guidelines)

1.3 Agenda Review

2 Review of Previous Meeting Minutes

3 Liaison Report

3.1 Facilities North America TC Chapter

3.2 Gases North America TC Chapter

3.3 Gases Europe TC Chapter

3.4 Facilities Korea TC Chapter

3.5 Semiconductor Components, Instruments, and Subsystems Technology Community (SCIS)

3.6 Electronic Materials Group (EMG)

3.7 Staff Report

4 Ballot Review

None

5 Subcommittee & Task Force Reports

5.1 Gases Japan TC Chapter

5.2 Facilities Japan TC Chapter

5.2.1 F1 Revision Task Force

5.2.2 5-year-review Task Force

6 Old Business

7 New Business



8 Action Item Review

8.1 Open Action Items

8.2 New Action Items

9 Next Meeting and Adjournment